

RECEIVED
CENTRAL FAX CENTER

7184485922

T-764 P.001/012 F-575

AUG 25 2005

PTO/SB/25 (08/03)
Approved for use through 07/31/2008. OMB 0651-0031
Patent and Trademark Office, U.S. DEPARTMENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Certificate of Transmission under 37 CFR 1.8

4612

Serial No. 09/546,174

Application of: Chih-Chien Liu, Ta-Shan Tseng, W. B. Shieh, J. Y. Wu, Water Lur and Shih-Wei Sun

Filed: April 11, 2000

Art Unit: 17.11

Examiner: Sergeant, Rabon A.

Attorney Docket No. UMC-96-279 CON (JIA-462C1)

For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS

Confirmation No.: 4793

Customer No.: 25235

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office

1. Supplemental Amendment.

on

25 August 2005
Date12No. of Pages
(incl. Coversheet)

to centralized fax number: 571-273-8300


SignatureJulie Lange

Typed or printed name of person signing Certificate

Note: Each paper must have its own certificate of transmission, or its certificate must identify each submitted paper.

Client Reference No. 81848.0016.001

Fax No. 719-448-5922

RECEIVED
CENTRAL FAX CENTER**AUG 25 2005**Client Matter No. 81848.0016.001
Via Facsimile**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No. 09/546,174 Application of: Chih-Chien Liu, Ta-Shan Tseng, W. B. Shieh, J. Y. Wu, Water Lur and Shih-Wei Sun Filed: April 11, 2000 Art Unit: 1711 Examiner: Sergeant, Rabon A. Attorney Docket No. UMC-96-279 CON (JIA-462C1) For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS	Confirmation No.: 4793 Customer No.: 25235
---	---

SUPPLEMENTAL AMENDMENT AND RESPONSE**MAIL STOP AMENDMENT**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.**Remarks/Arguments** begin on page 11 of this paper.